



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Luetzen, *et al.* Docket No.: INF115
Serial No.: 10/721,225 Art Unit: 1763
Filed: November 26, 2003 Examiner: George A. Goudreau
For: Method and Structures for Increasing the Structure Density and the Storage
Capacitance in a Semiconductor Wafer

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

The following amendments and remarks are presented in response to the Examiner's
Office Action mailed May 12, 2006. Please amend the above-referenced application as follows.